

Delphine Le Cunff received a Bachelor of Engineering in material sciences from the National Institute of Applied Science (INSA) at Rennes (France) in 1992. She continued with a Ph.D. degree in physics at University of Grenoble (France) in 1995. She started her carrier in semiconductor industry as an application engineer working for Therma-Wave a major optical metrology supplier from 1997 to 2006. She then joined STMicroelectronics in Crolles (France) where she held different technical and management positions in metrology area. She is now Senior Member of Technical Staff and is currently involved in innovation and development in the field metrology, process control and manufacturing sciences. Her activities cover applications from compound semiconductors to advanced technology nodes.